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CCS H 83

SJ

**INDUSTRY STANDARD OF THE
PEOPLE'S REPUBLIC OF CHINA**

SJ/T 11502-2015

**Specification for polished monocrystalline silicon carbide
wafers**

碳化硅单晶抛光片规范

(English Translation)

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What this standard covers

This Standard specifies the terms and definitions of polished silicon carbide single product, grade, requirements, test methods, inspection rules, and packaging, labeling, storage and transportation and so on. This Standard applies to the product type 6H and 4H, single-sided or double-sided polishing, diameter of 100mm and below the silicon carbide single crystal polished. Size or other crystalline silicon carbide single crystal can be polished using a reference.

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GB/T 6619; GB/T 6620; GB/T 6621; GB/T 13387; GB/T 13388; GB/T 14264; GB/T 30866; GB/T 30867; GB/T 30868; SJ/T 11499; SJ/T 11500; SJ/T 11501; SJ/T 11503; SJ/T 11504